

Atty. Dkt No  
33082M112

**ATTN: OFFICE OF INITIAL PATENT EXAMINATION'S CUSTOMER SERVICE CENTER**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yuji KAMIKAWA

Serial No.: 10/024,175

COPY OF PAPERS  
ORIGINALLY FILED

Group Art Unit: 1746

Filed: December 21, 2001

Examiner: To Be Assigned

For : SYSTEM FOR PROCESSING SUBSTRATE WITH LIQUID

**REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT**

**ATTN: OFFICE OF INITIAL PATENT EXAMINATION'S  
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Commissioner for Patents  
Washington, D.C. 20231

Sir:

A marked-up copy of the Official Filing Receipt in the above-referenced application is attached. It is respectfully requested that a corrected Official Filing Receipt be issued with the following correction:

1. please correct the number of drawings to -11--.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP



00441

PATENT TRADEMARK OFFICE

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February 6, 2002

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 UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/024,175	12/21/2001	1746	1064	33082M112	10	24	6

CONFIRMATION NO. 6309

## FILING RECEIPT



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## Applicant(s)

Yuji Kamikawa, Tosu-Shi, JAPAN;

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2000-392322 12/25/2000

If Required, Foreign Filing License Granted 01/29/2002

Projected Publication Date: 06/27/2002

Non-Publication Request: No

Early Publication Request: No

## Title

System for processing substrate with liquid

## Preliminary Class

134

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 TC 1700

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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